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CONFIRMATION NO. 7

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SERIAL NUMBER 10/706,914	FILING DATE 11/14/2003  RULE	CLASS 156	GROUP ART UNIT 1763	ATTORNEY DOCKE NO. 245161US3 CIP
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## APPLICANTS

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## \*\* CONTINUING DATA \*\*\*\*\*

This application is a CIP of 10/330,092 12/30/2002

*ku*  
3/3/05

## \*\* FOREIGN APPLICATIONS \*\*\*\*\*

*NONE*  
*ku*  
3/3/05

## F REQUIRED, FOREIGN FILING LICENSE GRANTED

\*\* 02/10/2004

Foreign Priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no	STATE OR	SHEETS	TOTAL	INDEPENDENT
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance	COUNTRY	DRAWING	CLAIMS	CLAIMS
Verified and Acknowledged Examiner's Signature <i>[Signature]</i> Initials <i>[Initials]</i>	JAPAN	7	3	1

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## TITLE

Wafer processing apparatus having dust proof function

FILING FEE

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900

FEES: Authority has been given in Paper  
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